

Supporting information:

Micro-Nano Machining TiO₂ Patterns without Residual Layer by Unconventional Imprinting

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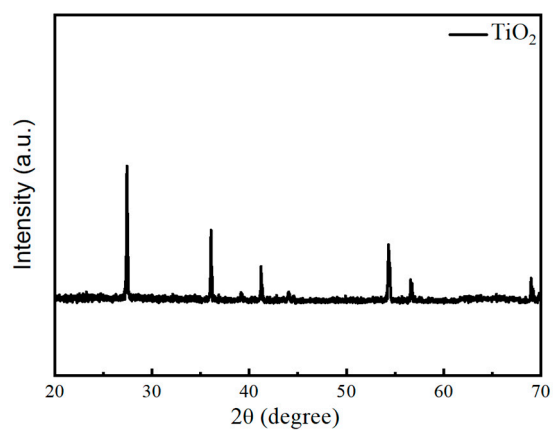


Figure S1. X-ray diffraction patterns of TiO₂.